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# CVD controlled growth of large-scale WS<sub>2</sub> monolayers

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Monolayer tungsten disulfide (WS<sub>2</sub>) with a direct band gap of ca. 2.0 eV and stable properties has been a hotspot in two-dimensional (2D) nanoelectronics and optoelectronics. However, it remains challenging to successfully prepare monolayer WS<sub>2</sub>. In this paper, we report the chemical vapor deposition (CVD) growth behavior of hexagonal WS<sub>2</sub> monolayers by using WS<sub>2</sub> powders and sodium trisulfate (Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub>) as precursors. We observed the Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub> has a significant effect on the WS<sub>2</sub> triangular and leaf-like shapes. In addition, based on proposed S-termination and W-termination theory, the growth mechanisms for different shapes of WS<sub>2</sub> were discussed.

## 1. Introduction

In recent years, transition metal dichalcogenides with tunable band gap have attracted tremendous interest.<sup>1</sup> Monolayer tungsten disulfide (WS<sub>2</sub>) with a direct band gap ca. 2.0 eV, shows potential applications in the fields of light emitting diodes, photodetectors, sensors, catalysts *etc.*<sup>2–6</sup> Before the practical application, many efforts have been focused on the preparation. Approaches, such as physical and chemical exfoliation, chemical synthesis, atomic layer deposition, laser annealing, physical vapor deposition and chemical vapor deposition have been reported.<sup>6–21</sup> Among them, exfoliation, chemical synthesis and chemical vapor deposition are the most used methods. Exfoliation is a versatile method for the low cost, scalable production of monolayer 2D materials.<sup>6–10</sup> High crystal quality of monolayer WS<sub>2</sub> prepared by this method is beneficial for fundamental property studies.<sup>10</sup> Small size, nonuniform thickness, and agglomeration in solution are drawbacks of this method. Chemical synthesis, such as the reaction of H<sub>3</sub>PW<sub>12</sub>O<sub>40</sub> with H<sub>2</sub>S, thermolysis of (NH<sub>4</sub>)WS<sub>4</sub> and organometallic precursors, is facile but hard to obtain large-area film.<sup>12–15</sup>

Chemical vapor deposition (CVD) is an efficient, scalable method to grow large-scale monolayer WS<sub>2</sub> film aiming for the fabrication of integrated device.<sup>16,17</sup> Tungsten oxides (WO<sub>3</sub>), metallic tungsten, WCl<sub>6</sub>, W(CO)<sub>6</sub>, (NH<sub>4</sub>)<sub>6</sub>H<sub>2</sub>W<sub>12</sub>O<sub>40</sub>·XH<sub>2</sub>O, WS<sub>2</sub> are used as tungsten precursor.<sup>22–27</sup> The most utilized CVD process is the sulfurization of WO<sub>3</sub> powders in sulfur vapor.<sup>27–40</sup> However, the crystal quality was influenced by various

experimental parameters, such as metal catalyst, pressure, substrate, the time of S-precursor introduction, temperature and location of precursor and substrate, carrier gas flow, pretreatment of the precursor or not, and growth temperature.<sup>33,41–43</sup> The growth mechanism is unclear and under discussing. Wu *et al.* investigated the growth of MoS<sub>2</sub> by sulfurization and found that sulfur enough condition promoted MoS<sub>2</sub> film growth. They suggested that the film growth is determined by the background sulfur concentration.<sup>44</sup> In our previous work, we also proposed that a delegation of tungsten precursor and an excess of sulfur are the predominate reasons for the monolayer growth.<sup>2</sup> Cain *et al.* investigated the nucleation and they found that monolayer growth belongs to heterogeneous nucleation growth on oxo-chalcogenide nanoparticles.<sup>45</sup> Therefore, the monolayer WS<sub>2</sub> growth is complicated and mechanism is unclear. The CVD method needs to be further investigated.

To decrease the high melting point of the precursor should be considered before the controllable and reproducible CVD growth of WS<sub>2</sub>. To solve this problem, molten salt was introduced, such as sodium chloride (NaCl). Li *et al.* and Zhou *et al.* reported the alkali metal halides assisted growth of atomically thin metal dichalcogenides at relatively low temperature. Intermediate product volatile oxyhalides (as intermediate products) are considered as a promoter for monolayer growth.<sup>46,47</sup> Modtland *et al.* prepared monolayer WS<sub>2</sub> by chemical vapor transport deposition using WS<sub>2</sub> as a precursor and NaCl as a transport agent. They suggested that nonvolatile WS<sub>2</sub> reacts with NaCl to form gaseous tungsten chloride and sulfur.<sup>48</sup> Wang *et al.* synthesized MoS<sub>2</sub>-WS<sub>2</sub> in-plane heterostructures by ambient pressure chemical vapor deposition. They suggested Na-containing intermediate product is formed, which reduces the reaction energy.<sup>49</sup> In addition, Lin *et al.* obtained 2H and 1T phase monolayer WS<sub>2</sub> with assistance of iron oxide and NaCl.<sup>50</sup>

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Shogo *et al.* prepared Nb-doped WS<sub>2</sub> monolayers with the halide-assisted chemical vapor deposition (CVD).<sup>51</sup>

In this paper, we investigated the growth behavior of monolayer WS<sub>2</sub> with WS<sub>2</sub> powders and sodium trisulfate (Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub>) as precursor in Ar/H<sub>2</sub> atmosphere. Utilization of Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub> is based on the following consideration. Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub> differs from commonly used flux NaCl in that Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub> not only serves as the flux, but also the sulfur-rich precursor. Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub> will react with H<sub>2</sub> to form excess H<sub>2</sub>S at high temperature, which can benefit the enhancement of WS<sub>2</sub> crystal quality. Although, lots of work on the NaCl promoted growth of WS<sub>2</sub> has been done, the role of sodium ions played is unclear.<sup>52</sup> Here, we obtained separated triangular domains and continuous leaf-like film by CVD method at a relatively low temperature. In addition, we discussed the growth mechanism of leaf-like shape WS<sub>2</sub> and the role of sodium salt. We believe our finds could provide a clue to prepare other 2D materials.

## 2. Experimental

### Monolayer WS<sub>2</sub> growth

WS<sub>2</sub> monolayer was prepared by co-firing WS<sub>2</sub> powders and Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub> in a sealed tube. Fig. 1 shows growth setup consisting of a tube furnace and vacuum system. WS<sub>2</sub> powders and solid Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub> were used as precursor. Silicon wafer with 300 nm of oxide layer (SiO<sub>2</sub>/Si) (100 × 15 mm) was used as the growth substrate. Before growth, the precursor (mixture of 0.1 g WS<sub>2</sub> and 0.1 g Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub>) was loaded into a quartz boat (80 × 10 mm) and placed in the center of the tube (25.4 mm in diameter). The substrate was covered on the quartz boat with the SiO<sub>2</sub> side facing down to the precursor. For the growth of WS<sub>2</sub> layers with triangular shape, the furnace tube was heated to 500 °C from room temperature in 40 min with 30 sccm Ar/H<sub>2</sub> (5% H<sub>2</sub>). Then

the tube was sealed at an atmospheric pressure and kept at 500 °C for 1 h before the tube was cooled to room temperature, naturally. For the growth of leaf-like WS<sub>2</sub> film, the furnace tube temperature was 700 °C. Other experimental parameters kept unchanged.

### Characterization

Optical and photoluminescence (PL) imaging was taken on a Jiangnan MV3000 digital microscope and a Nib400 fluorescence microscope (Jiangnan Novel Optics Co., Ltd.), respectively. Scanning electron microscopy (SEM) was conducted on a desktop scanning electron microscope (COXEM EM-30 AX Plus). PL and Raman spectra were acquired on a home-built Raman system, consisting of an inverted microscope (Ti eclipse, Nikon), a Raman spectrometer (iHR320, Horiba) with a CCD camera (Syncerity, Horiba) and a semiconductor laser at 532 nm.

## 3. Results and discussion

We observed the triangular WS<sub>2</sub> crystals were grown on the substrate. Fig. 2a and c show optical microscopy image of WS<sub>2</sub> layers with a triangular shape. Different contrast colors represent different thickness of WS<sub>2</sub> (see discussion in Fig. 3). The triangular areas circled in black, red, green and blue colors are bulk, monolayer, bilayer and multilayer in Fig. 2c, respectively. The size of the monolayer WS<sub>2</sub> domain is *ca.* 12.7 μm. The possible reason to why the domain cannot grow up is the low surface energy of the substrate. The hexagonal WS<sub>2</sub> crystal can be assumed to begin from a hexagonal nucleus with three sides of W atom terminations and three sides of S atom terminations. When the W : S atomic ratio is less than 1 : 2, W terminations

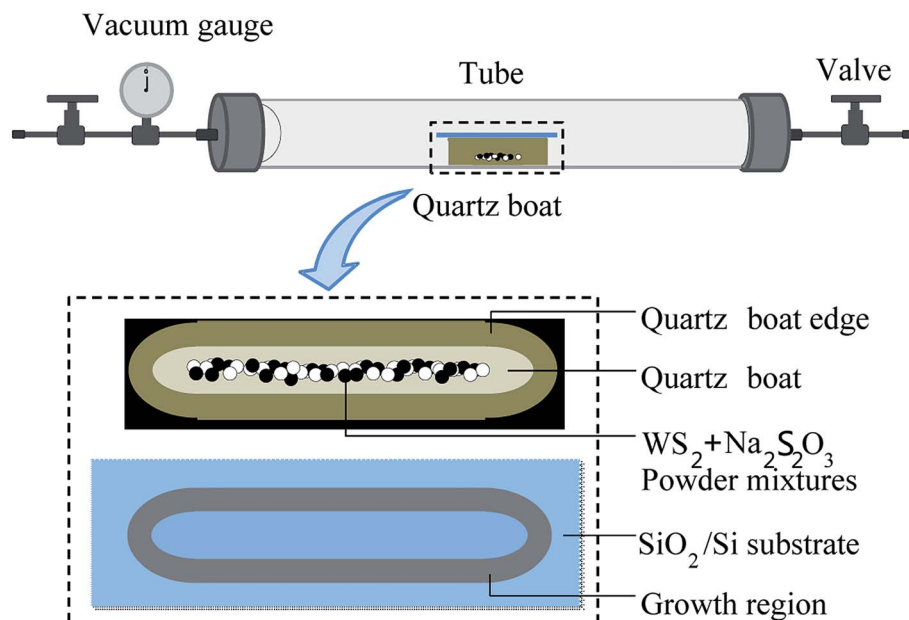


Fig. 1 Schematic diagram of monolayer WS<sub>2</sub> growth setup (upper), quartz boat and precursor (middle) and growth region (bottom) on SiO<sub>2</sub>/Si substrate. Growth zone shape is consistent with the edge of the quartz boat.



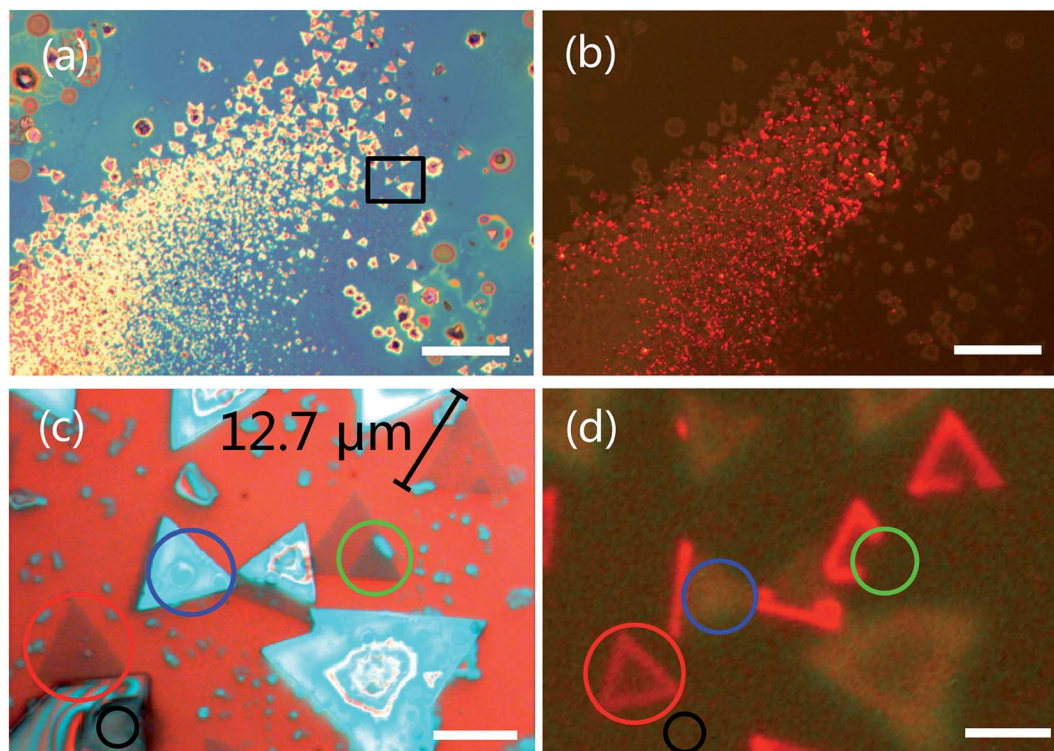


Fig. 2 Optical microscopy (a) and photoluminescence (PL) (b) images of WS<sub>2</sub> layers grown on SiO<sub>2</sub>/Si substrate. (c) Magnified optical microscopy and corresponding PL images taken from the boxed area in (a). (a) and (b) were taken at same location. The scale bars in figure (a) and (b) represent 100 μm, and 10 μm in (c) and (d). The red color in (b) and (d) is due to the PL emission of monolayer WS<sub>2</sub>.

will grow faster than S terminations to become smaller or disappear until the hexagonal WS<sub>2</sub> crystal grows to triangular in S rich structure. When the W : S atomic ratio is larger than 1 : 2, S terminations will grow faster than W terminations to become smaller or disappear until the hexagonal WS<sub>2</sub> crystal grows to triangular in W rich structure. Both of these two cases could result in triangular shape WS<sub>2</sub> growth. Therefore, the unbalanced the S and W termination growth at three sides of original hexagon could result in triangular WS<sub>2</sub> growth.<sup>53,54</sup> In this experiment, S source is sufficient from Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub>, resulting in triangular WS<sub>2</sub> growth.

Fig. 2b and d show PL images from monolayer WS<sub>2</sub> with 485 nm excitation wavelengths. Being different from the indirect band gap of multilayer, monolayer has a direct band structure with high external quantum efficiency. Therefore, we only observed bright PL emission from monolayer WS<sub>2</sub> with 485 nm excitation wavelengths in Fig. 2b and d. Clearly, the edge of the WS<sub>2</sub> domain (circled in red color in Fig. 2d) shows intensive PL emission. Inhomogeneous PL intensity within a monolayer domain (circled in red color in Fig. 2d) is due to the uniformity of composition and defects from the center to the edge.<sup>52</sup>

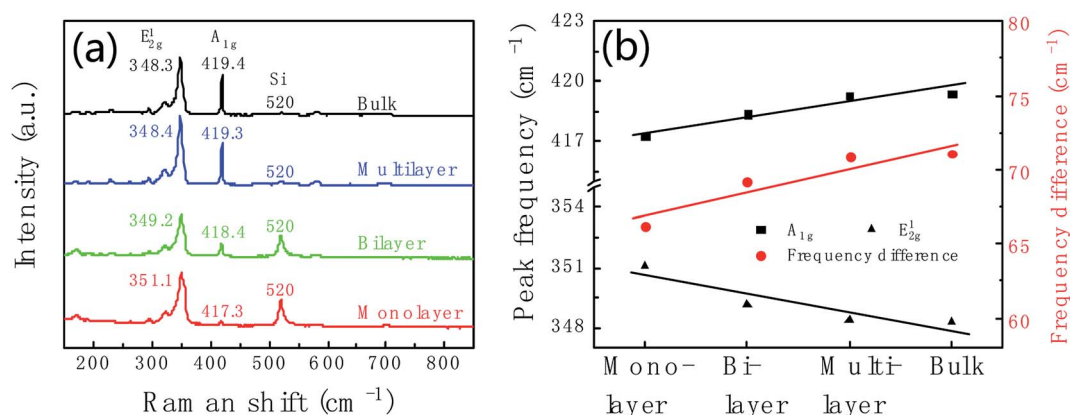


Fig. 3 (a) Raman spectra of monolayer (red line), bilayer (green line), multilayer (blue line) and bulk (black line) WS<sub>2</sub> corresponding to the sample in Fig. 2c. (b) Thickness dependent of Raman peak position and the peak frequency difference between E<sub>2g</sub><sup>1</sup> and A<sub>1g</sub>.



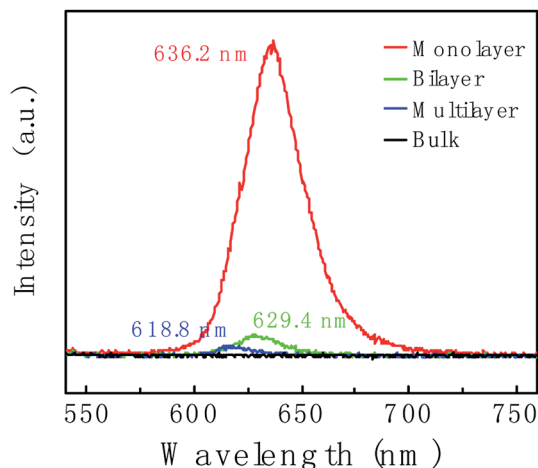


Fig. 4 Photoluminescence (PL) spectra of WS<sub>2</sub> layers corresponding to the region marked with a red circle, blue circle, green circle and black circle in Fig. 2c, respectively.

Raman spectrum is commonly used to identify the layer number of WS<sub>2</sub> layer. Fig. 3a shows Raman spectra of WS<sub>2</sub> layers at room temperature with 532 nm laser excitation corresponding to the marked regions in Fig. 2c. The Raman data was calibrated by the Raman peak of Si at 520 cm<sup>-1</sup>. Two main peaks at 351.1 cm<sup>-1</sup> and 417.3 cm<sup>-1</sup> are characteristic Raman peaks of monolayer WS<sub>2</sub>. The peak at 351.1 cm<sup>-1</sup> is due to the in-plane

phonon mode E<sub>2g</sub><sup>1</sup>, and 417.3 cm<sup>-1</sup> for the out-of plane mode A<sub>1g</sub>. Therefore, the triangular domain circled in red color in Fig. 2c is monolayer WS<sub>2</sub>. The peak position and peak frequency difference between the two modes are the function of the number of WS<sub>2</sub> layers. With the increase of the layer number, the E<sub>2g</sub><sup>1</sup> peak position decreases from 351.1 cm<sup>-1</sup> of monolayer to 348.3 cm<sup>-1</sup> of bulk; and the A<sub>1g</sub> peak position increases from 417.3 cm<sup>-1</sup> of monolayer to 419.4 cm<sup>-1</sup> of bulk. The peak frequency difference increases with the increase of the thickness shown in Fig. 3b. The frequency differences are 66.2 cm<sup>-1</sup>, 69.2 cm<sup>-1</sup>, 70.9 cm<sup>-1</sup>, and 71.1 cm<sup>-1</sup> corresponding to monolayer, bilayer, multilayer and bulk, respectively.

Fig. 4 shows the thickness-dependent PL spectra of WS<sub>2</sub>. An intense PL emission peak in the monolayer (red line) at 636.2 nm is observed, which is due to the A<sup>-</sup> exciton emission. Compare to the monolayer, the PL intensity of bilayer (green line) is decreased by *ca.* 10-fold. For the multilayer (blue line), the PL intensity was further decreased. In bulk WS<sub>2</sub> (black line), PL emission is hardly observed. Different behaviors in PL lie in the different band gap structures. Not like multilayer, monolayer has a direct band gap structure thus resulting in the intense PL emission. In addition, the PL peak position shows blueshift. We suspect the blueshift maybe be due to the defects and stress in the sample.<sup>55,56</sup>

Besides the triangular WS<sub>2</sub> domains, we also observed the leaf-like WS<sub>2</sub> film in Fig. 5. Fig. 5a and c are the optical

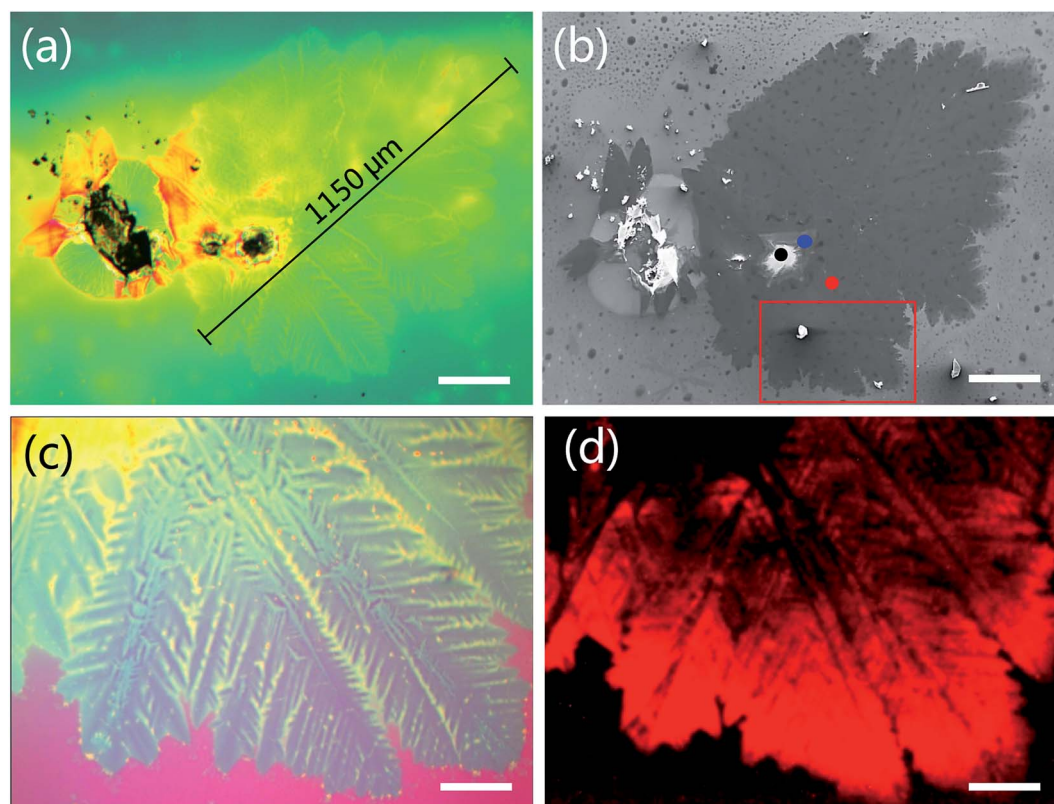


Fig. 5 Optical microscopy (a) and SEM (b) images of WS<sub>2</sub> film taken at the same location. (c) Magnified optical microscopy image of (a). (d) The photoluminescence (PL) image corresponding to the sample of (c). (c) and (d) are taken at the same location. The red color in (d) is due to the PL emission of monolayer WS<sub>2</sub>. The scale bars in figure (a), (b), (c) and (d) represent 200 μm, 200 μm, 50 μm and 50 μm, respectively.



microscopy images of the leaf-like WS<sub>2</sub> film. Fig. 5d is the PL image corresponding to the sample in Fig. 5c. The bright red color is due to the monolayer. The shape size is up to 1150 μm (Fig. 5a). Inside is bulk WS<sub>2</sub> (marked with black dot in Fig. 5b). Around the bulk WS<sub>2</sub> is multilayer WS<sub>2</sub> (dark lines in Fig. 5d) extending in all direction like leaf veins. Continuous monolayer WS<sub>2</sub> (red color in Fig. 5d) connects the multilayer. The thickness is determined by following Raman and PL data in Fig. 6. This unique interconnection of the WS<sub>2</sub> domains will benefit the future large-scale application in optoelectronics such as photodetectors in which the monolayer of WS<sub>2</sub> could capture the excitation light signal and the generated free carriers could transport through the “leaf veins” channels of the multilayer of WS<sub>2</sub>.

Fig. 6a and b shows the Raman and PL spectra of WS<sub>2</sub> at different locations corresponding to the regions marked with red, blue and black spots in Fig. 5b. For the region marked with red color, Raman peaks of E<sub>2g</sub><sup>1</sup> and A<sub>1g</sub> are at 351.2 cm<sup>-1</sup> and 417.0 cm<sup>-1</sup>, respectively, with peak frequency difference of 65.8 cm<sup>-1</sup> (red curve in Fig. 6a). As well as this region shows intensive PL emission at 631.2 nm. These features indicate that

the region marked with a red dot in Fig. 5b is monolayer WS<sub>2</sub>. By further analysis, we found the regions marked with blue and black dots in Fig. 5b are multilayer and bulk, respectively. Fig. 6c is XPS of leaf-like domain showing W atomic ratio is 0.1% and S atomic ratio is <0.1%. Therefore, W : S atomic ratio is larger than 1 : 2. Carbon is from CO<sub>2</sub> which was adsorbed on the surface of sample. Silicon is from substrate.

Here, the leaf-like shape WS<sub>2</sub> growth mechanism should be different from the triangular WS<sub>2</sub> and more like kinetically limited growth (Fig. 7). We suspect that the leaf-like shape is due to the preferential orientation growth. The above-mentioned triangle growth is due to preferential growth with W terminations. However, the preferential growth of leaf-like shape is S terminations. Sodium ions (Na<sup>+</sup>) from the sodium trisulfate (Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub>) precursor is diffused all over the Si substrate during the heating up steps, wherein S terminations will absorb the Na<sup>+</sup> to form sodium-passivated S terminations, resulting the terminated chemical reaction between S and W and the further growth of WS<sub>2</sub> (Fig. 7a). At 500 °C, Na<sup>+</sup> is physically adsorbed on substrate surface, so the absorption quantity is so little that there is no obvious effect on resulting

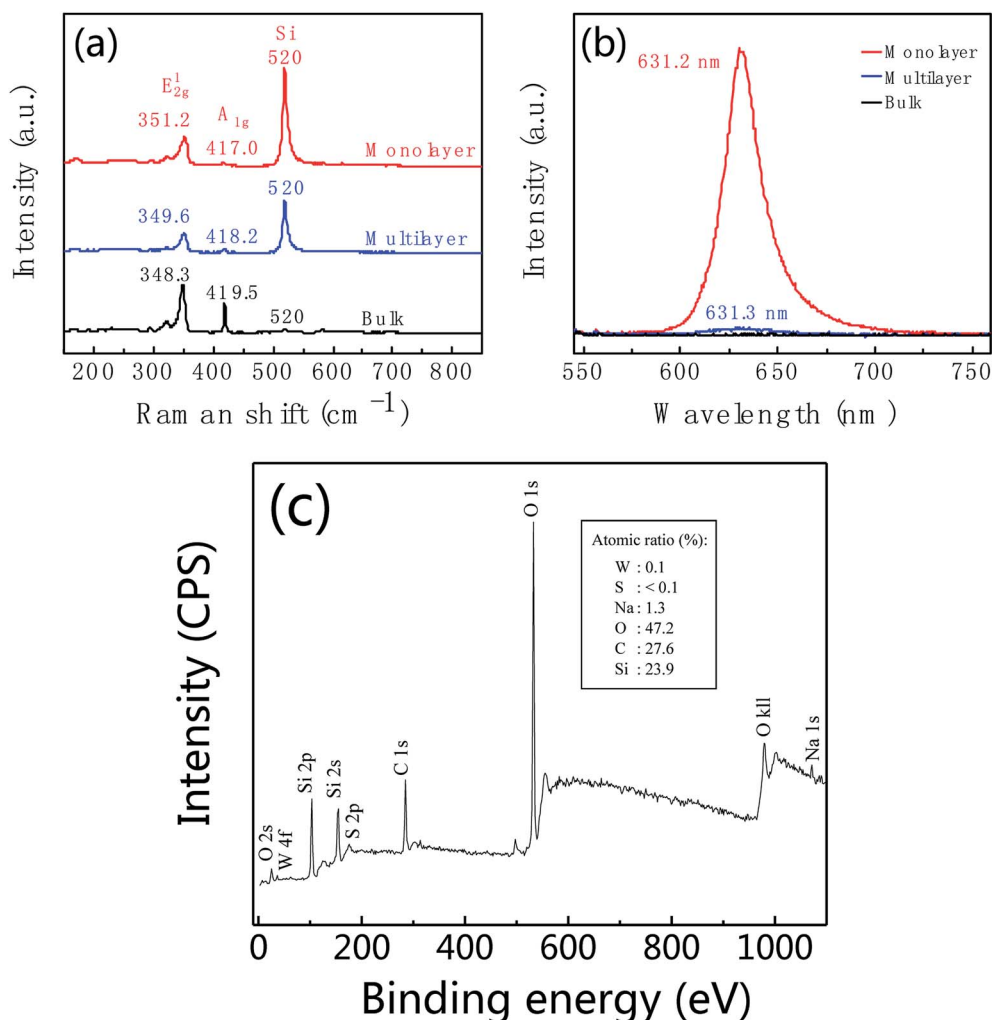


Fig. 6 Raman (a) and photoluminescence (b) spectra of WS<sub>2</sub> taken from the regions marked with red, blue and black spots in Fig. 5b. (c) XPS of leaf-like domain of as-prepared WS<sub>2</sub>. Insert is atomic ratio.



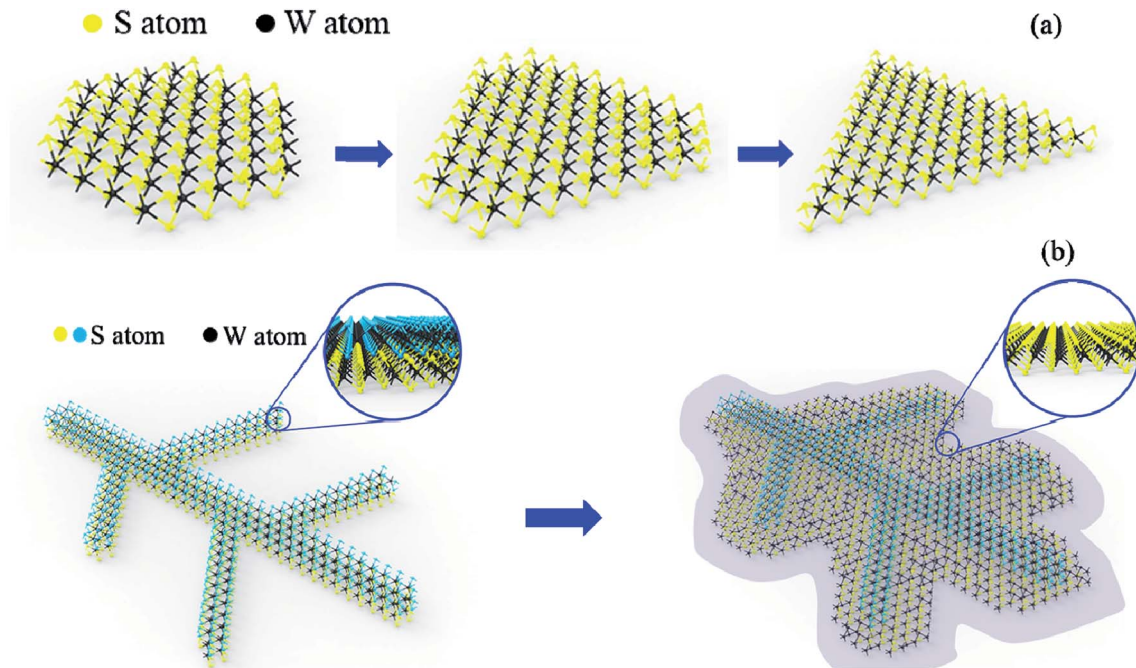


Fig. 7 Schematic drawing of the growth mechanism of (a) triangular  $\text{WS}_2$  and (b) leaf-like  $\text{WS}_2$ .

sodium-passivated S termination. Thus, preferential growth of triangle shape is W terminations. At  $700\text{ }^\circ\text{C}$ ,  $\text{Na}^+$  is chemically adsorbed on substrate surface, so the absorption quantity is enough to result sodium-passivated S termination. As a result, the preferential growth of leaf-like shape is S terminations (Fig. 7b) which is consistent with the XPS results that the W and S atomic ratio is larger than 1 : 2. The defects are introduced combined with the faster growth and lead to the multilayer growth with Stranski–Krastanow mode (SK mode) which refers to layer plus island growth: 2D film grows on the surface of substrate and there is distortion due to lattice mismatch between film and substrate. Then, the 2D film will adsorb the deposited atoms, forming islands in the way of nucleation growth, and eventually grows into film. Therefore, the “leaf veins” (in Fig. 5c and d) are produced. Followed the growth of “leaf veins”, is the relatively slow-growing S terminations as shown in the inset of Fig. 7b, where triangular shape of  $\text{WS}_2$  could be formed to successfully fill the gaps among the branched leaf veins. Therefore, the interconnected  $\text{WS}_2$  in large scale has been formed.

## 4. Conclusion

In conclusion, we have successfully prepared  $\text{WS}_2$  layers by CVD with the  $\text{WS}_2$  and  $\text{Na}_2\text{S}_2\text{O}_3$  as precursors.  $\text{Na}_2\text{S}_2\text{O}_3$  used as sulfur precursor and molten salt has a significant effect on the film growth. Triangular and leaf-like shapes of  $\text{WS}_2$  film were obtained. The S-termination could absorb the  $\text{Na}^+$  to form sodium-passivated S terminations and terminate the further growth of  $\text{WS}_2$ , resulting the triangular shape of  $\text{WS}_2$ . On contrast, the W-termination grows much faster than the S-termination, resulting the leaf vein shape growth of  $\text{WS}_2$ . Followed the growth of

“leaf veins”, there are more locations of S-termination in the branched veins of  $\text{WS}_2$  which is favorable for triangular  $\text{WS}_2$  growth to fill the gaps among the various veins in the leaf structured  $\text{WS}_2$ . Therefore, the controllable  $\text{WS}_2$  layers have been demonstrated with  $\text{Na}_2\text{S}_2\text{O}_3$  precursors as growth motivators which could provide informative guidance for future large-scale 2D growth.

## Conflicts of interest

There are no conflicts of interest to declare.

## Acknowledgements

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